

PATENT YOR920040022 IBM-272

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Matthew Colburn, et al.

Serial Number : 10/799,282

Filing Date : March 13, 2004

Examiner : John A. McPherson

Group Art Unit : 1756

For : Method for Fabricating Dual Damascene Structures

Using Photo-Imprint Lithography, Methods for Fabricating Imprint Lithography Molds for Dual Damascene Structures, Materials for Imprintable Dielectrics and Equipment for Photo-Imprint Lithography Used in Dual Damascene Patterning.

TO: The Honorable Commissioner of Patents and Trademarks Post Office Box 1450 Alexandria, VA 22313-1450

CHANGE OF ADDRESS

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Respectfully Submitted,

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I hereby certify that this paper is being transmitted by First Class mail addressed to Commissioner of Patents & Trademarks, Post Office Box 1450, Alexandria, VA 22313-1450.

Signature:

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Date: June 30, 2007

Name: